

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L3	22	(US-20020014205-\$ or US-20030219536-\$).did. or (US-4816638-\$ or US-5185689-\$ or US-5271732-\$ or US-5273423-\$ or US-5340261-\$ or US-5435683-\$ or US-5578129-\$ or US-5727392-\$ or US-5735961-\$ or US-5795399-\$ or US-5879458-\$ or US-6066538-\$ or US-6287984-\$ or US-6383927-\$ or US-6623798-\$).did. or (JP-10050619-\$).did. or (US-4160680-\$ or JP-06177053-\$ or JP-10294428-\$ or JP-11150109-\$).did.	US-PGPUB; USPAT; JPO; DERWENT	OR	ON	2005/05/04 15:00
L4	3	3 and ("mfc" "mass flow controller")	US-PGPUB; USPAT	OR	ON	2005/05/04 15:04
L5	327	c23c016\$.ipc. and ("mfc" "mass flow controller")	EPO; JPO; DERWENT	OR	ON	2005/05/04 15:02
L6	0	c23c016\$.ipc. and ("mfc" "mass flow controller") and (load\$3 with lock\$3)	EPO; JPO; DERWENT	OR	ON	2005/05/04 15:02
L7	1	c23c016\$.ipc. and ("mfc" "mass flow controller") and (load\$3)	EPO; JPO; DERWENT	OR	ON	2005/05/04 15:03
L8	0	c23c016\$.ipc. and ("mfc" "mass flow controller") and (lock\$3)	EPO; JPO; DERWENT	OR	ON	2005/05/04 15:03
L9	123	(load\$3 with lock\$3) same ("mfc" "mass flow controller")	US-PGPUB; USPAT	OR	ON	2005/05/04 15:04
L10	17	(load\$3 with lock\$3) with ("mfc" "mass flow controller")	US-PGPUB; USPAT	OR	ON	2005/05/04 15:04
S1	15	(load\$3 with lock\$3) same (air with "water vapor")	US-PGPUB; USPAT	OR	ON	2004/11/05 14:36
S2	0	(load\$3 with lock\$3) same (air with "water vapor")	EPO; JPO; DERWENT	OR	ON	2004/11/05 14:36
S3	0	c23c016\$.ipc. and (load\$3) same (air with "water vapor")	EPO; JPO; DERWENT	OR	ON	2004/11/05 14:36
S4	0	c23c016\$.ipc. and (load\$3) same (air same "water vapor")	EPO; JPO; DERWENT	OR	ON	2004/11/05 14:37
S5	0	c23c016\$.ipc. and ((load\$3) same (air same "water vapor"))	EPO; JPO; DERWENT	OR	ON	2004/11/05 14:37
S6	3	(substrate wafer semiconductor workpiece) and ((load\$3) same (air same "water vapor"))	EPO; JPO; DERWENT	OR	ON	2004/11/05 14:38
S7	265	(substrate wafer semiconductor workpiece) and ( (air same "water vapor"))	EPO; JPO; DERWENT	OR	ON	2004/11/05 14:38
S8	217	(substrate wafer semiconductor workpiece) and ( (air with "water vapor"))	EPO; JPO; DERWENT	OR	ON	2004/11/05 14:38
S9	13	"5735961".URPN.	USPAT	OR	ON	2004/11/05 15:05
S10	11	("4369031"   "5273423"   "5277579"   "5378283"   "5388944"   "5407350"   "5433785"   "5462397"   "5527390"   "5551984"   "5562383").PN.	USPAT	OR	ON	2004/11/05 15:12
S11	20	(US-6066538-\$ or US-6623798-\$ or US-6383927-\$ or US-5185689-\$ or US-5271732-\$ or US-5273423-\$ or US-4816638-\$ or US-5340261-\$ or US-5435683-\$ or US-5578129-\$ or US-5727392-\$ or US-5735961-\$ or US-5879458-\$ or US-6287984-\$ or US-5795399-\$).did. or (JP-10050619-\$).did. or (JP-10294428-\$ or JP-11150109-\$ or JP-06177053-\$ or US-4160680-\$).did.	USPAT; JPO; DERWENT	OR	OFF	2004/11/05 15:43
S12	5	S11 and filter	US-PGPUB; USPAT	OR	ON	2004/11/05 15:58
S13	10	(S9 S10) and filter	US-PGPUB; USPAT	OR	ON	2004/11/05 16:38
S14	33	shin-ju-cheol.in. park-in-sun.in. kim-young-cheon.in. whang-bo-chul.in.	US-PGPUB; USPAT	OR	ON	2004/11/05 16:40
S15	3	whang-bo-chul.in.	US-PGPUB; USPAT	OR	ON	2004/11/05 16:39

S16	3	((("6221771") or ("5923988") or ("5780360"))).PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2004/11/03 17:31
S17	0	("7086253").PN.	USOCR; EPO; JPO; DERWENT	OR	OFF	2004/11/03 17:31
S18	1	"07086253"	EPO; JPO; DERWENT	OR	ON	2004/11/03 17:33
S19	0	"7086253"	EPO; JPO; DERWENT	OR	ON	2004/11/03 17:32
S20	0	"7086253"	EPO; JPO; DERWENT	OR	ON	2004/11/03 17:33
S21	1	"60237265"	EPO; JPO; DERWENT	OR	ON	2004/11/03 17:33
S22	20	(118/719.ccls. 156/345.31.ccls. 156/345.32.ccls. 414/939.ccls.) and (load\$3 same lock same (water with vapor))	US-PGPUB; USPAT	OR	ON	2004/11/03 17:39
S23	8	(118/719.ccls. 156/345.31.ccls. 156/345.32.ccls. 414/939.ccls.) and (load\$3 same lock same air same (inert argon nitrogen noble) same oxygen )	US-PGPUB; USPAT	OR	ON	2004/11/03 17:40
S24	8	(118/719.ccls. 156/345.31.ccls. 156/345.32.ccls. 414/939.ccls.) and (load\$3 same lock\$3 same air same (inert argon nitrogen noble) same oxygen )	US-PGPUB; USPAT	OR	ON	2004/11/03 17:40
S25	10	(load\$3 same lock\$3 same air same (inert argon nitrogen noble) same oxygen )	EPO; JPO; DERWENT	OR	ON	2004/11/03 17:56
S26	1	("6623798").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2004/11/03 18:02
S27	1	("6066538").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2004/11/03 18:05
S28	9	("5185689"   "5501999"   "5534457"   "5552334"   "5607874"   "5686337"   "5702989"   "5910218"   "5981404").PN.	USPAT	OR	ON	2004/11/03 18:03
S29	0	"6066538".URPN.	USPAT	OR	ON	2004/11/03 18:03
S30	0	"11150109".URPN.	USPAT	OR	ON	2004/11/03 18:05
S31	1	("6383927").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2004/11/03 18:06
S32	0	"6383927".URPN.	USPAT	OR	ON	2004/11/03 18:06
S33	5	("4415385"   "5204075"   "5295668"   "5928786"   "5953630"). PN.	USPAT	OR	ON	2004/11/03 18:06
S34	52	(load\$3 same lock\$3 same air same (inert argon nitrogen noble) same oxygen )	US-PGPUB; USPAT	OR	ON	2004/11/03 18:21
S35	3	(load\$3 with lock\$3) same ((supply\$3 introduc\$3 inlet enter\$3) with air with "water vapor")	US-PGPUB; USPAT	OR	ON	2004/11/05 14:31
S36	477	(load\$3 with lock\$3) same ((supply\$3 introduc\$3 inlet enter\$3) with air )	US-PGPUB; USPAT	OR	ON	2004/11/03 18:14
S37	338	(load\$3 with lock\$3) same ((supply\$3 introduc\$3 ) with air )	US-PGPUB; USPAT	OR	ON	2004/11/03 18:14
S38	45	(118/719.ccls. 156/345.31.ccls. 156/345.32.ccls. 414/939.ccls.) and ( (load\$3 with lock\$3) same ((supply\$3 introduc\$3 ) with air ) )	US-PGPUB; USPAT	OR	ON	2004/11/03 18:15